

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.: 10/621,464
Applicant: Wayne L. Johnson et al.
Art Unit: 1763
Examiner: MacArthur, Sylvia
Title: **VERTICALLY TRANSLATABLE CHUCK ASSEMBLY AND
METHOD FOR A PLASMA REACTOR SYSTEM**
Attorney Docket: PC0109A
Confirmation No.: 1154

Chandler, Arizona 85226

August 7, 2007

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

RESPONSE TO ELECTION/RESTRICTION REQUIREMENT

This paper is responsive to the Office Action dated July 16, 2007. The Examiner has indicated that claims 1, 2, 5-17, 19-30, and 32-36 are pending in the application and are subject to restriction and/or election requirement. Specifically, we understand that the Examiner has grouped the claims between Group I, claims 1, 2, 5-14, Group II, claims 26-28, Group III, claims 29, 30, 32-34, and Group IV, claims 15-17, 19-25, 35, 36. Group I is directed to a chuck assembly, Group II to a match network, Group III to a method for using a match network, and Group IV to a plasma reactor.

Applicants hereby elect Group I, claims 1, 2, 5-14, directed to a chuck assembly, without traverse. Examination on the merits of elected claims 1, 2, 5-14 is respectfully requested. Applicant reserves the right to file divisional applications for the non-elected claims in the future, if necessary or desired.

Application No. 10/621,464
Response dated August 7, 2007
to Office Action mailed July 16, 2007

Please charge our Deposit Account No. 50-3451 for any additional fee(s) that may be due in this matter, and please credit the same deposit account for any overpayment.

Respectfully submitted,

TOKYO ELECTRON U.S. HOLDINGS, INC.

By: /Eric J. Strang/
Eric J. Strang, Reg. No. 54,472

4350 W. Chandler Blvd, Suite 10
Chandler, AZ 85226
(480) 539-2109 (voice)
(480) 539-2100 (facsimile)